

03500.016245



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JUNJI KAWASAKI

Application No.: 10/086,562

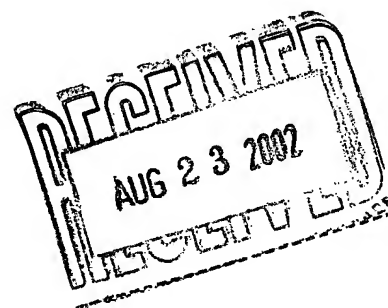
Filed: March 4, 2002

For: METHOD OF FABRICATING  
ELECTRON SOURCE SUBSTRATE  
AND IMAGE FORMING  
APPARATUS

Examiner: NYA

Group Art Unit: 2879

July 17, 2002



Commissioner for Patents  
Washington, D.C. 20231

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is also enclosed.

The Examiner's attention is also directed to the following U.S. Application:

APPLICATION NO.

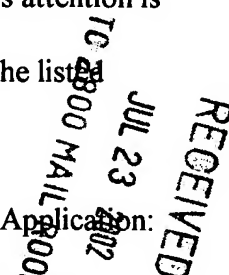
FILING DATE

GROUP ART UNIT

09/788,411

2/21/01

2812



A copy of the cited Application is enclosed.

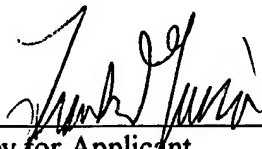
For the concise explanation of relevance for the Japanese document listed on the enclosed Form PTO-1449, the Examiner is respectfully referred to Application No. 09/788,411, which is an English-language counterpart of that Japanese document.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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Attorney for Applicant

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